

Special Issue

Graphene based Electronic Devices

Message from the Guest Editor

Graphene has gained interest as a promising material in future electronic devices due its high conductance and potential for the flexible modification of its electronic and structural properties. In this Special Issue of *Micromachines*, researchers and developers are invited to submit manuscripts for the Special Issue “Graphene-Based Electronic Devices”, where we wish to focus on advancements in the fabrication and characterization of different electronic structures. Articles, short communications, and review articles are all welcome that cover a broad range of possible topics, including fabrication and characterization of graphene and graphene oxide thin films; graphene-based batteries and fuel cells; photovoltaics; graphene for flexible electronics and display; and other new applications and circuits based on graphene and graphene oxide. All submissions will be reviewed in accordance with the normal procedures of *Micromachines*.

Guest Editor

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Deadline for manuscript submissions

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Message from the Editor-in-Chief

You are invited to contribute research articles or comprehensive reviews for consideration and publication in *Micromachines* (ISSN 2072-666X). *Micromachines* is published in the open access format. Research articles, reviews and other contents are released on the internet immediately after acceptance. The scientific community and the general public have unlimited free access to the content as soon as it is published. As an open access journal, *Micromachines* is supported by the authors or their institutes by payment of article processing charges (APC) for accepted papers. We are pleased to welcome you as our authors.

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